



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
Group Art Unit 1763

In re Patent Application of

Jui-Ping LI, et al.

Application No. 09/546,936

Docket No. 201056-0052

Filed: 11 April 2000

Examiner: MOORE, Karla A.

APPARATUS FOR FORMING FILM IN  
SEMICONDUCTOR PROCESS AND METHOD  
FOR FEEDING GAS INTO THE SAME  
APPARATUS

I, Kelly Ray, hereby certify that this correspondence is being deposited with the US Postal Service as first class mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on the date of my signature.

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PRELIMINARY AMENDMENT

TO: Box RCE  
Assistant Commissioner for Patents  
Washington, DC 20231

- [X] AUTHORIZATION TO PAY AND PETITION FOR THE ACCEPTANCE OF ANY NECESSARY FEES: If any charges or fees must be paid in connection with the following Communication (including but not limited to the payment of issue fees), they may be paid out of our deposit account No. 50-1965. If this payment also requires a Petition, please construe this authorization to pay as the necessary Petition, which is required to accompany the payment.

In conjunction with the RCE mailed 10 February 2003 prior to examination, please amend the application as follows: